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					U.S.	PATENT DOCU	JMENTS			rconnolo	gy Center 200
Exam. Initial		Docur	nent Numbe	r		Date	Name		Class	Sub Class	Filing Date
di	DV	5 101	155			2/2/1002	Uashim	ata at al			12/21/1000

Exam. Initial		Document Number	Date	Name	Class	Sub Class	Filing Date
de	BY	5,191,455	3/2/1993	Hashimoto et al.			12/21/1990
dy	BZ	6,323,833	11/27/2001	Takeuchi et al.			3/23/1998
C							
					2.2		

U.S. COPENDING APPLICATIONS

Exam. Initial	Application Number	Our Docket No.	Filing Date	Inventor Name	Class	Sub Class

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	Sub Class	Translation	Abstract
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OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages etc.)

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Examiner:	Vincent	E. Kovelsck	Date	Considered: 5/22 0	ے

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US DEPARTMENT OF COMMERCE III 1 2001	Atty Docket	No. 789_067	Serial No.	09/803,744
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STATEMENT BY APPLICANE	Filing Date	March 8, 2001	Group	Not Assigned
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U.S. PATENT DOCUMENTS

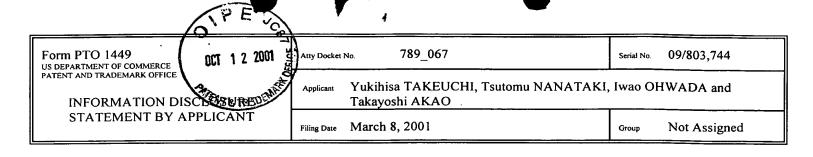
Exam, Initial		Document Number	Date	Name	Class	Sub Class	Filing Date
UC	AV	5,861,863	1/19/1999	Kudo et al.			
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					Technology (énter 26	00
	8						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub Class	Translation	Abstract
we	AW	11282420	10/15/1999	Japan	-			
W	AX	7007709	1/10/1995	Japan				
ule	AY	11085104	3/30/1999	Japan				
all	AZ	7287536	10/31/1995	Japan				
W	ВА	6282241	10/7/1994	Japan				
We	вв	9198007	7/31/1997	Japan				

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages Etc.)

	j.
Examiner Vincent E. Kuvalielk	Date Considered /5/22-63



U.S. PATENT DOCUMENTS

Exam. Initial		Document Number	Date	Name	Class	Sub Class	Filing Date	
1)45	BD	5,754,160	5/19/1998	Shimizu et al.			-	
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				<u> </u>				$-\parallel$
				17	11			-1
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FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub Class	Translation	Abstract
VIL_	ВС	0 852 371 A1	7/8/1998	Europe				
				D	7			

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages Etc.)

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Examiner	Vincent E.	Kovaluek	Date Considered	5/ 22/07	

Form PTO 1449 us department of commerce	Atty Docket No. 789_067 Serial No. 09/803,744					
US DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE	Applicant Yukihisa TAKEUCHI, Tsutomu NANATAKI Takayoshi AKAO	I, Iwao OHWADA and				
STATEMENT BY APPLICANT	Filing Date March 8, 2001	Group Not Assigned				

/MT	OR	U.S. PATENT DOCU	MENTS			
Exam.	Document Number	Date	Name	Class	Sub Class	Filing Date
PROFILAR	5,106,181	April 21, 1992	Rockwell, III			
V			-			
					DE	PENE
					חר	CT 2 4 2001
						
					GR	DUP 30
		/			<u> </u>	

FOREIGN PATENT DOCUMENTS

Document Number	Date	Country	Class	Sub Class	Translation	Abstract
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		1			1000	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages Etc.)

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Examiner V	incent E. Kovalick	Date Considered $S(2202)$

Form PTO 1449 US DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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Applicant Yukihisa TAKEUCHI, Tsutomu NANATAKI, Iwao OHWADA a Ri Takayoshi AKAO

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iling Date Concurrently Herewith

U.S. PATENT DOCUMENTS

							n_ ==
Exam. Initial		Document Number	Date	Name -	Class	Sub Class	Filing Date
Jak	AA	5,636,072	6/3/1997	Shibata et al.		-	
	AB	5,862,275	1/19/1999	Takeuchi et al.			
	AC	5,774,257	6/30/1998	Shibata et al.			
	AD	6,028,978	2/22/2000	Takeuchi et al.			
	AE	4,113,360	9/12/1978	Baur et al.			
	AF	5,771,321	6/23/1998	Stern A			
	AG	5,953,469	9/14/1999	Zhou			
)	AH	6,091,182	7/18/2000	Takeuchi et al.			
M	AI	6,108,479	8/22/2000	Takeuchi et al.			

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub Class	Translation	Abstract
100	AJ	10-078549	3/24/1998	JP				V
	AK	7-28717,6	10/31/1995	JР				~
	AL	54-142089	11/5/1979	JР				~
	AM	11-202222	7/30/1999	JP				·
	AN	11-072721	3/16/1999	JP				~
U	AO	0 408 305 B1	3/13/1996	EP		4	-	
ω_{ζ}	AP	0 675 477 A1	10/4/1995	ЕР			~	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages Etc.)

U	AQ	Kazuo Anzai, "Preparation of Electronic Materials by Electrophoretic Deposition," General Institute of Toshiba Corporation, DENKI KAGAKU 53, No. 1, 1985; pp 63 to 68 (with English Translation).				
M	AR	Atsushi Goto et al., "PbZrO ₃ /PbTiO ₃ Composite Ceramics Fabricated by Electrophoretic Deposition," Tokyo Metropolitan University, Tokyo Medical and Dental University, Proceedings of First Symposium on Higher-Order Ceramic Formation Method Based on Electrophoresis, 1998, pp 5 and 6 (with English Translation).				
II	AS	Kimihiro YAMASHITA, "Hybridization of Ceramics by Electrophoretic Deposition," Institute for Medical and Dental Engineering, Tokyo Medical and Dental University, Proceedings of First Symposium on Higher-Order Ceramic Formation Method Based on Electrophoresis, 1998, pp 23 and 24 (with English Translation).				
Exami	ner	Vincent E. Kovælirk Date Considered 5/2×103				